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#6-7-01  
#GP/3823  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: AZAM, MIZBAHUL, et al.  
Serial No.: 09/705,274  
Filing Date: November 3, 2000  
Group Art Unit: 2814  
Examiner: Unknown  
Title: TRENCH GROWTH TECHNIQUES USING  
SELECTIVE EPITAXY

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WASHINGTON, D.C. 20231, ON: May 25, 2001

Date of Deposit

SEMICONDUCTOR COMPONENTS INDUSTRIES, LLC

Name of Assignee

Julie Hall  
SIGNATURE

May 25, 2001  
DATE

SUBMITTAL OF FORMAL DRAWINGS

Honorable Commissioner of Patents and Trademarks,  
Washington, D.C. 20231  
Attn: **Official Draftsperson**

SIR:

We are hereby submitting three (3) sheets of formal  
drawings for the above-identified patent application.

Respectfully submitted,

Michael T. Wallace

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